



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Uzoh et al.  
 Appl. No. : 10/698,878  
 Filed : October 31, 2003  
 For : METHODS AND DEPOSITING  
 HIGH YIELD AND LOW  
 DEFECT DENSITY  
 CONDUCTIVE FILMS IN  
 DAMASCENE STRUCTURES  
 Examiner : Van, Luan V.  
 Group Art Unit : 1753

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 5, 2006

(Date)

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**AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**

**Mail Stop AF**

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Final Office Action mailed on April 5, 2006. Please amend the above-identified application as set forth herein and consider the remarks that follow.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.